



cas 12/21/05 6427-65559-01 466919

AF
JFW

PATENT
Attorney Reference Number 6427-65559-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: James F. Orsillo

Application No. 10/695,245

Filed: October 27, 2003

Confirmation No. 4337

For: APPARATUS AND METHOD FOR USE IN
TESTING A SEMICONDUCTOR WAFER

Examiner: Jermele M. Hollington

Art Unit: 2829

Attorney Reference No. 6427-65559-01

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: MAIL STOP AF, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney or Agent
for Applicant(s)

Date Mailed December 22, 2005

MAIL STOP AF
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

TRANSMITTAL LETTER

Enclosed for filing in the application referenced above are the following:

- ☒ Amendment After Allowance.
- ☒ The Director is hereby authorized to charge any additional fees that may be required, or credit over-payment, to Deposit Account No. 02-4550. A copy of this sheet is enclosed.
- ☒ Please return the enclosed postcard to confirm that the items listed above have been received.

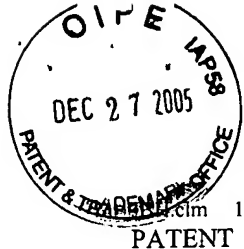
Respectfully submitted,

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By

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12/21/05 464553

PATENT

Attorney Reference Number 6427-65559-01

Application Number 10/695,245

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Response Under 37 C.F.R. § 1.116 Expedited Procedure

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AMENDMENT AFTER ALLOWANCE

Please amend the referenced application as follows:

Amendments to the Specification begin on page 2.

Remarks begin on page 3.